1765 TC\$

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

§

in re Application of:

Mok, et al.

Serial No.: 09/785,815

Confirmation No.: 4127

Filed:

February 16, 2001

For:

INTEGRATED

SEMICONDUCTOR SUBSTRATE BEVEL

CLEANING APPARATUS AND

METHOD

MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 1763

Examiner:

Sylvia R. MacArthur

CERTIFICATE OF MAILING 37 CFR 1.8

I hereby certify that this correspondence is being deposited on July 6, 2004 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

7/3/0Y Date

Signature

RESPONSE TO OFFICE ACTION DATED APRIL 13, 2004

In response to the Office Action dated April 13, 2004, having a shortened statutory period for response set to expire on July 13, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/APPM/2601.P11/KMT, the fee of \$86.00 for one additional independent claim. If any additional fees are due in connection with this response, the Commissioner is counsel's Deposit hereby authorized to charge Account No. 20-0782/APPM/2601.P11/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Specification begin on page 2 of this paper. Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper. Remarks begin on page 8 of this paper.

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